

<b>AMENDMENT</b>		Docket No. F0017/7000
Applicant:	Jiankang Huang and Robert C. O'Handley	
Serial No:	10/730,355	
Filed:	December 8, 2003	
For:	HIGH SENSITIVITY, PASSIVE MAGNETIC FIELD SENSOR AND METHOD OF MANUFACTURE	
Examiner:	C. A. Renner	
Art Unit:	2652	

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**In response to the office communication dated August 16, 2006, please amend the above-identified application as follows:**

**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.